

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

IN RE APPLICATION OF: Koji USUDA, et al.

GAU:

SERIAL NO:

EXAMINER:

FILED:

FOR: SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE SAME

**REQUEST FOR PRIORITY**

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

- Full benefit of the filing date of U.S. Application Serial Number 09/717,039, filed November 22, 2000, is claimed pursuant to the provisions of **35 U.S.C. §120**.
- Full benefit of the filing date(s) of U.S. Provisional Application(s) is claimed pursuant to the provisions of **35 U.S.C. §119(e)**:  
Application No. \_\_\_\_\_ Date Filed \_\_\_\_\_
- Applicants claim any right to priority from any earlier filed applications to which they may be entitled pursuant to the provisions of **35 U.S.C. §119**, as noted below.

In the matter of the above-identified application for patent, notice is hereby given that the applicants claim as priority:

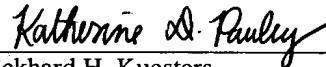
<b>COUNTRY</b>	<b>APPLICATION NUMBER</b>	<b>MONTH/DAY/YEAR</b>
Japan	11-336059	November 26, 1999

Certified copies of the corresponding Convention Application(s)

- are submitted herewith
- will be submitted prior to payment of the Final Fee
- were filed in prior application Serial No. 09/717,039 filed November 22, 2000
- were submitted to the International Bureau in PCT Application Number  
Receipt of the certified copies by the International Bureau in a timely manner under PCT Rule 17.1(a) has been acknowledged as evidenced by the attached PCT/IB/304.
- (A) Application Serial No.(s) were filed in prior application Serial No. \_\_\_\_\_ filed \_\_\_\_\_; and
- (B) Application Serial No.(s)
  - are submitted herewith
  - will be submitted prior to payment of the Final Fee

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND,  
MAIER & NEUSTADT, P.C.

  
\_\_\_\_\_  
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